

<b>Notice of References Cited</b>	Application/Control No. 10/074,889	Applicant(s)/Patent Under Reexamination MOCK ET AL.	
	Examiner Gabriel L. Chu	Art Unit 2114	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,819,156	04-1989	DeLorme et al.	714/15
	B	US-4,843,541	06-1989	Bean et al.	710/36
	C	US-5,596,747	01-1997	Katabami et al.	707/101
	D	US-5,727,203	03-1998	Hapner et al.	707/103R
	E	US-5,966,713	10-1999	Carlsund et al.	707/200
	F	US-6,249,792	06-2001	Zwilling et al.	707/205
	G	US-6,289,355	09-2001	Haderle et al.	707/200
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.